

Kazuyuki Iizuka

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/11017486/publications.pdf>

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3
papers

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2258059

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2550090

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docs citations

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times ranked

76
citing authors

#	ARTICLE	IF	CITATIONS
1	Highly sensitive SnO ₂ porous film gas sensors fabricated by plasma spray physical vapor deposition. Sensors and Actuators B: Chemical, 2012, 173, 455-461.	7.8	31
2	Growth of tin oxide thick films by plasma spray physical vapor deposition. Sensors and Actuators B: Chemical, 2011, 155, 551-556.	7.8	12
3	Highly sensitive formaldehyde sensors based on catalyst added porous films fabricated by plasma spray physical vapor deposition. Sensors and Actuators B: Chemical, 2013, 182, 250-255.	7.8	8